



- Drafts
- Pending
- Active
  - L61: (14514) opto-electronic or opto adj el
  - L62: (27) 61 and ((substrate with packag\$
  - L63: (365) 61 and (controller and heat\$3)
  - L64: (14) 63 and (substrate and bump\$1)
  - L65: (1) 61 and (electrical adj controller an
- Failed
- Saved
  - (34234) opto-electronic or optical adj switc
  - (2) (opto-electronic or optical adj switch\$2
  - (3) (opto-electronic or optical adj switch\$2
  - (54) (opto-electronic or optical adj switch\$2
- Favorites
- Tagged (0)
- UDC
- Queue
- Trash

DBs: USPAT US-PGPUB EPO JPO DERWENT IBM TDB  Blurs

Default operator: OR  Highlight all hit terms initially

(opto-electronic or optical adj switch\$2 or planar adj lightwave adj circuit\$1 or thermo-optic adj switch or opto adj electronic or thermo adj optic adj switch) and ((substrate with packag\$3) and solder adj bump\$1)

BRIEF  1549  1549  Text  HTML

#	U	I	Document ID	Issue Date	Pages	Title	Current OR	Current XRef
1	<input type="checkbox"/>	<input type="checkbox"/>	US 20030140698 A1	20030731	26	High voltage drive circuitry aligned with MEMS array	73/514.18	
2	<input type="checkbox"/>	<input type="checkbox"/>	US 20030133478 A1	20030717	23	Tunable diffractive device	372/20	
3	<input type="checkbox"/>	<input type="checkbox"/>	US 20030131476 A1	20030717	18	Heat conduits and terminal radiator for microcircuit packaging and manufacturing	29/890.03	29/557
4	<input type="checkbox"/>	<input type="checkbox"/>	US 20030122263 A1	20030703	5	Flip-chip opto-electronic circuit	257/778	
5	<input type="checkbox"/>	<input type="checkbox"/>	US 20030122206 A1	20030703	10	Multi-chip module integrating MEMS mirror array with electronics	257/415	257/418; 257/419
6	<input type="checkbox"/>	<input type="checkbox"/>	US 20030112298 A1	20030619	31	Lattice array-structured piezoelectric actuator and method for producing the	347/68	
7	<input type="checkbox"/>	<input type="checkbox"/>	US 20030081287 A1	20030501	27	OPTICAL COMMUNICATION SWITCH NODE	398/52	398/45
8	<input type="checkbox"/>	<input type="checkbox"/>	US 20030057535 A1	20030327	17	Techniques for attaching rotated photonic devices to an optical sub-assembly in an	257/678	257/222
9	<input type="checkbox"/>	<input type="checkbox"/>	US 20030038297 A1	20030227	18	Apparatus, system, and method for transmission of information between	257/99	
10	<input type="checkbox"/>	<input type="checkbox"/>	US 20030031428 A1	20030213	11	Parallel electro-optic interface assembly	385/89	385/88
11	<input type="checkbox"/>	<input type="checkbox"/>	US 20030020062 A1	20030130	28	MEMS and method of manufacturing MEMS	257/40	

BRIEF  Details  HTML